

Sheet 1 of 1Form PTO-1449
(REV. 8-83)US Dept. of Commerce
PATENT & TRADEMARK OFFICEATTY DOCKET NO.
111704.01APPLICATION NO.
10/727,191

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANTS
Joel A. KUBBY et al.FILING DATE
December 3, 2003

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
<i>M</i>	6,168,395 B1	01/02/2001	Quenzer et al.	417	413.3
<i>M</i>	6,303,885 B1	10/16/2001	Hichwa et al.	200	181
<i>M</i>	5,909,078	06-1999	Wood et al.	310	307

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

<i>M</i>	Saif, "On a Tunable Bistable MEMS-Theory and Experiment", Journal of Microelectromechanical Systems, vol. 9, no. 2, pp. 157-170, June 2000.
<i>M</i>	Vangbo et al., "A lateral symmetrically bistable buckled beam", J. Micromech. Micreng., 8 (1998), pp. 29-32.
<i>M</i>	Qiu et al., "A Centrally-Clamped Parallel-Beam Bistable MEMS Mechanism," Massachusetts Institute of Technology, IEEE MEMS 2001 Conference Proceedings

EXAMINER

Robert C. Smith

DATE CONSIDERED

3/9/05

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: February 26, 2004